



PATENT
Attorney Docket No. 81877.0007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Norikazu MIZUNO et al

Serial No: 09/670,917

Confirmation No: 1895

Filed: September 29, 2000

For: Semiconductor Device Manufacturing
Method and Apparatus for Removing
Silicon Nitride Formed in a Reaction
Container

Art Unit: 2822

Examiner: Guerrero, Maria F.

I hereby certify that this correspondence
is being deposited with the United States
Postal Service with sufficient postage as
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Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450, on

April 25, 2005

Date of Deposit

Juanita Soberanis

Name

Juanita Soberanis 04/25/2005
Signature Date

PETITION FOR EXTENSION OF TIME

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Commissioner for a three-month extension of time extending to April 25, 2005, the period for response to the Office Action dated October 25, 2004. Please charge the fee of \$1020 for this extension to Deposit Account No. 50-1314. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-1314. A copy of this petition is enclosed.

04/27/2005 EAREGAY1 00000015 501314 09670917

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Date: April 25, 2005

Respectfully submitted,

HOGAN & HARTSON L.L.P.

By: *Troy M. Schmelzer*

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